	Application No.	Applicant(s)	
Notice of Allowability	10/623,341	KIM ET AL.	
	Examiner	Art Unit	
	Lan Vinh	1765	
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI	(OR REMAINS) CLOSED i or other appropriate comm GHTS. This application is:	n this application. If not included unication will be mailed in due course	
1. $\boxtimes$ This communication is responsive to <u>Amendment and resp</u>	onse filed on 7/15/2005.		
2. 🖾 The allowed claim(s) is/are <u>1-19</u> .			
3. 🖾 The drawings filed on 18 July 2003 are accepted by the Ex	aminer.		
<ul> <li>4. Acknowledgment is made of a claim for foreign priority un a) ☐ All b) ☐ Some* c) ☐ None of the: <ol> <li>Certified copies of the priority documents have</li> <li>Certified copies of the priority documents have</li> <li>Copies of the certified copies of the priority documents have</li> <li>Copies of the certified copies of the priority documents have</li> <li>International Bureau (PCT Rule 17.2(a)).</li> </ol> </li> <li>* Certified copies not received: <ol> <li>Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.</li> </ol> </li> </ul>	been received. been received in Application cuments have been received	on No d in this national stage application fro	
5. A SUBSTITUTE OATH OR DECLARATION must be submi INFORMAL PATENT APPLICATION (PTO-152) which give	tted. Note the attached EX s reason(s) why the oath o	AMINER'S AMENDMENT or NOTICE reduction is deficient.	OF
<ol> <li>CORRECTED DRAWINGS ( as "replacement sheets") must (a) including changes required by the Notice of Draftsperson.</li> <li>hereto or 2) to Paper No./Mail Date</li> <li>including changes required by the attached Examiner's Paper No./Mail Date</li> <li>Identifying indicia such as the application number (see 37 CFR 1.6 each sheet. Replacement sheet(s) should be labeled as such in the</li> </ol>	on's Patent Drawing Review Amendment / Comment of	r in the Office action of	of
<ol> <li>DEPOSIT OF and/or INFORMATION about the depose attached Examiner's comment regarding REQUIREMENT F</li> </ol>	SIT OF BIOLOGICAL MATE FOR THE DEPOSIT OF BIO	ERIAL must be submitted. Note the DLOGICAL MATERIAL.	e
<ul> <li>Attachment(s)</li> <li>1. ☐ Notice of References Cited (PTO-892)</li> <li>2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)</li> <li>3. ☒ Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date 062305</li> <li>4. ☐ Examiner's Comment Regarding Requirement for Deposit</li> </ul>	6. ☐ Interview S Paper No.  7. ☐ Examiner's  8. ☑ Examiner's	formal Patent Application (PTO-152) ummary (PTO-413), 'Mail Date Amendment/Comment Statement of Reasons for Allowance	
of Biological Material	9.	Lan Vinh AU 1765	/

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## Allowable Subject Matter

1. Claims 1-19 are allowed.

The following is an examiner's statement of reasons for allowance:

Regarding claims 1, 10, the applicants have presented a persuasive argument, see page 6 of the response filed on 7/15/2005, that the cited prior art of Rudeck, taken alone or in combination, fails to disclose or render obvious a method of manufacturing a semiconductor device comprising the step of "depositing a second polysilicon film on the entire structure and then planarizing the second polysilicon film so that the oxide film protrusion is exposed, thereby forming a floating gate having the second polysilicon film formed on the first polysilicon film/ depositing a second polysilicon film on the entire structure and then removing the second polysilicon film on the oxide film protrusion by means of CMP process, thereby forming a floating gate having the second polysilicon film formed on the first polysilicon film since Rudeck does not suggest planarizing the polysilicon layer 590/ removing the second polysilicon film by means of CMP process because Rudeck method requires the roughness of polysilicon layer 590 for additional deposition step (fig. 5F)

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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## Conclusion

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2. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Lan Vinh whose telephone number is 571 272 1471. The examiner can normally be reached on M-F 8:30-5:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine Norton can be reached on 571 272 1465. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

August 17, 2005